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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hogan et al.

Art Unit: 3742

Serial No.: 10/635,824

Examiner: Van, Quang T.

Filed: 6 August 2003

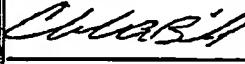
Docket No. TI-28996.1

For: METHOD FOR IMPROVING ASH RATE UNIFORMITY IN PHOTORESIST
ASHING PROCESS EQUIPMENT

EXTENSION OF TIME

22 October 2004

Assistant Commissioner for Patents
Washington, DC 20231

MAILING CERTIFICATE UNDER 37 C.F.R. 31.8(A)	
I hereby certify that the above correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on the date shown below.	
	22 Oct. 2004
Charles A. Brill	Date

Dear Sir:

Applicants respectfully petition the Commissioner, under 37 C.F.R. § 1.136(a), for an extension of the shortened statutory period for response in the above-identified Application.

The fee for this extension is indicated below:

One Month (\$110) Two Months (\$410) Three Months (\$930)
 Four Months (\$1,450) Five Months (\$1,970)

According to 37 C.F.R. § 1.17(k), please charge the fee to the deposit account of Texas Instruments Incorporated, Deposit Account No. 20-0668. Any further necessary extension of time is hereby requested. Please charge any and all fees to Deposit Account No. 20-0668. A duplicate of his form is submitted.

Respectfully submitted,



Charles A. Brill
Reg. No. 37,786

Texas Instruments Incorporated
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Dallas, TX 75265
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